Docket No. 2312-0866-2 PCT

## SPATENT AND TRADEMARK OFFICE IN THE UNITED STAT

IN RE APPLICATION OF: Kimihiro MATSUSE, et al.

SERIAL NO: 09/530,588

GAU:

2814

RCE FILED: December 18, 2003

EXAMINER: QUACH, T.

FOR:

METHOD OF FORMING SEMICONDUCTOR WIRING STRUCTURES

## REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

lt i	s hereby requested that a one month extension of time be granted to MAY 28, 2004 for
	filing a response to the Official Action dated: JANUARY 28, 2004
	responding to the requirements in the Notice of Allowability dated:
	filing the Formal Drawings. The Issue Fee due has been timely filed.
	responding to the Notice to File Missing Parts of Application dated:
	filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
	filing an Appeal Brief. A Notice of Appeal was filed on:
	Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.
The required fee of \$110.00 is enclosed herewith by credit card payment and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.	

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,

MAIER & NEUSTADT, P.C.

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